OCT 0 6 1999 B

PATENT APPLICATION

35.C11946

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: C. Dexter

AKIRA FUNAKOSHI, ET AL.

Group Art Unit: 3724

Application No.: 08/801,464

Filed: February 18, 1997

For: SUBSTRATE CUTTING METHOD )

AND SUBSTRATE CUTTING :

APPARATUS

October 6, 1999

The Assistant Commissioner for Patents Washington, D.C. 20231

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Group Sage

## **AMENDMENT**

Sir:

In response to the Official Action dated April 6,
1999, the period for response having been extended for three
months by the accompanying Petition for Extension of Time to and
including October 6, 1999, please amend the above-identified
application as follows:

10/07/1999 CVDRACHA 00000025 08801464

01 FC:103 02 FC:102 36.00 OP 156.00 OP